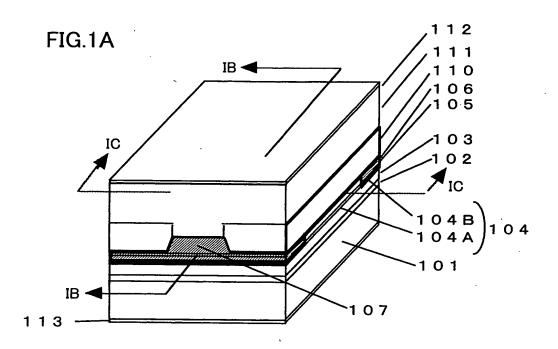
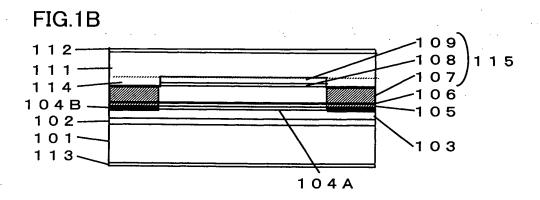
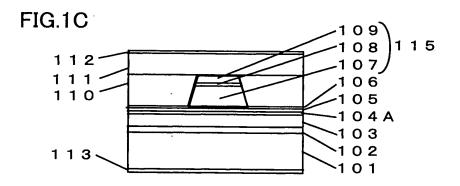
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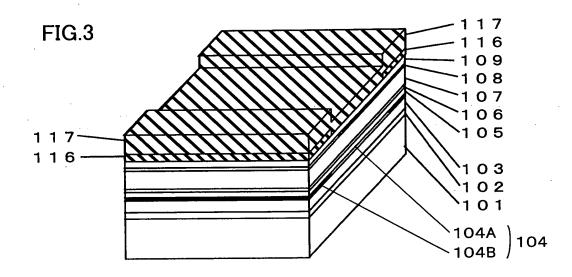


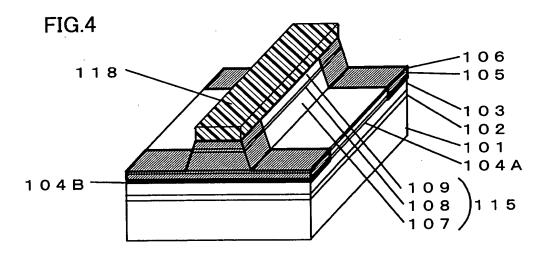


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FIG.2

109
108
107
106
105
104
103
102
101





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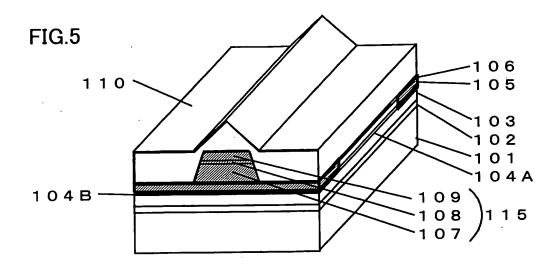
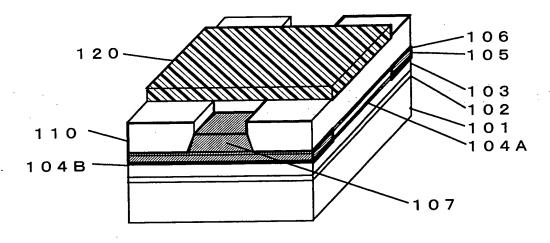
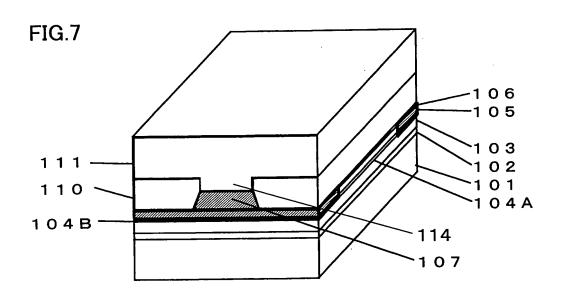


FIG.6





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FIG.8

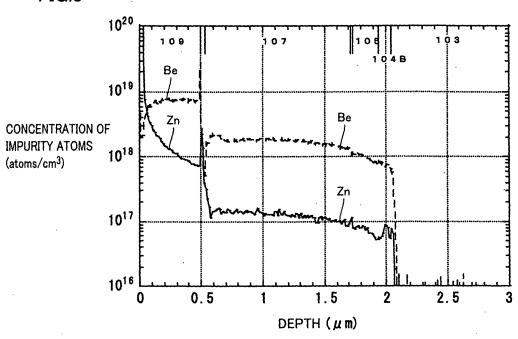
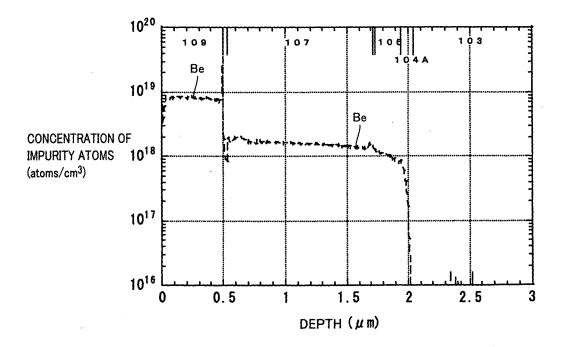


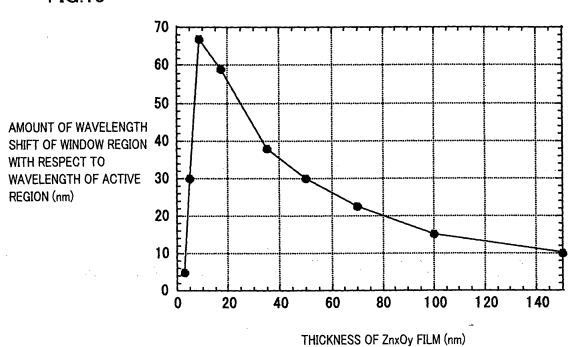
FIG.9



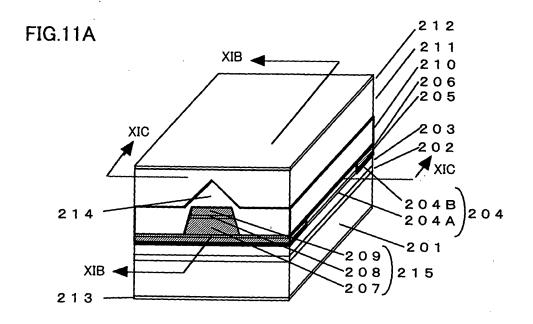
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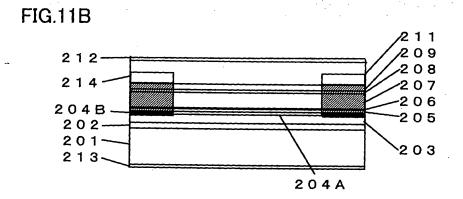
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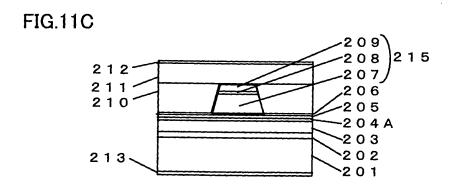
FIG.10



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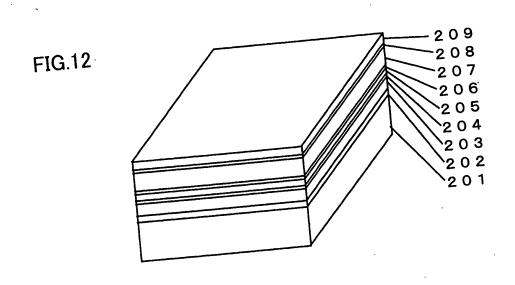


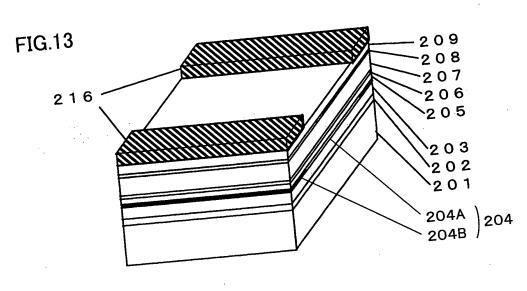


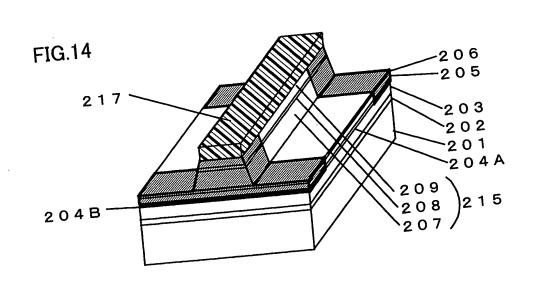
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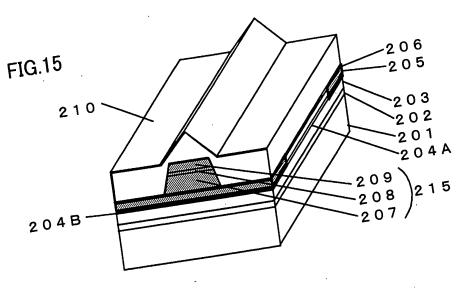


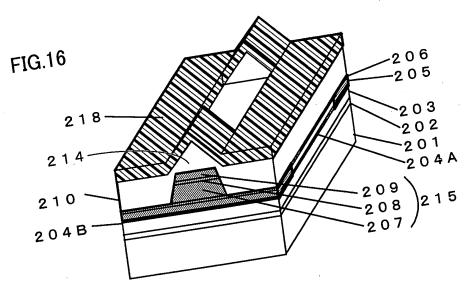


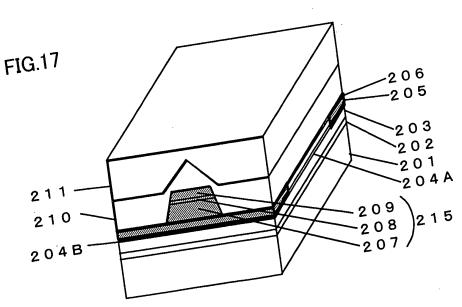


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FIG.18A PRIOR ART

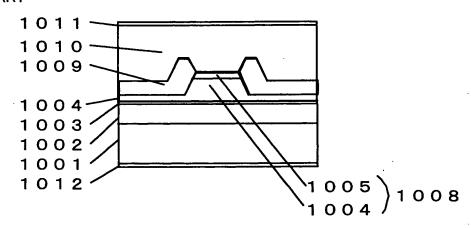


FIG.18B
PRIOR ART

1011
1009
1004
1003
1002
1001
1012

FIG.18C
PRIOR ART

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FIG.19 PRIOR ART

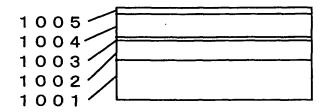
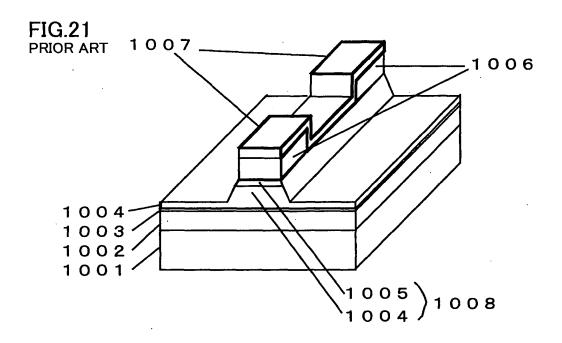


FIG.20
PRIOR ART

1006

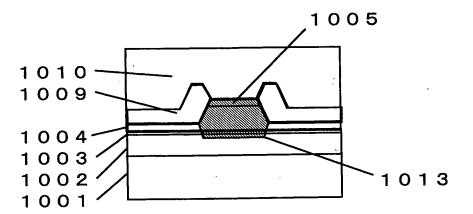
1005
1004
1003
1002
1001



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FIG.22 PRIOR ART



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